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Complete if Known	
Application No.	10/751,328
Filing Date	December 31, 2003
First Named Inventor	Feng Xie <i>et al.</i>
Art Unit	Not Yet Assigned
Examiner Name	Not Yet Assigned
Attorney Docket Number	23564-08653

U.S. PATENT DOCUMENTS				
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OTHER REFERENCES – NON-PATENT LITERATURE DOCUMENTS				
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S ^b	C1	REEVES, William T., et al., "Approximate and Probabilistic Algorithms for Shading and Rendering Structured Particle Systems," Siggraph '85, Vol. 19, July 1985, No. 3, pp. 313-322.		
S ^b	C2	DUFF, Tom, et al., "Compositing 3-D Rendered Images," Siggraph '85, Vol. 19, July 1985, No. 3, pp. 41-44.		
S ^b	C3	REEVES, William T., "Particle Systems – Technique for Modeling a Class of Fuzzy Objects," Computer Graphics, Vol. 17, No. 3, July 1983, pp. 359-376		

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Examiner Signature	<i>Sam Broome</i>	Date Considered	1 - 10 - 2006
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609.

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